

ELECTRONIC INFORMATION DISCLOSURE STATEMENT

Electronic Version v18

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Title of Invention	METHODS FOR HIGH-PRECISION GAP AND ORIENTATION SENSING BETWEEN A TRANSPARENT TEMPLATE AND SUBSTRATE FOR IMPRINT LITHOGRAPHY
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Application Number : 09/920341



Confirmation Number: 4146

First Named Applicant: Byung Choi

Attorney Docket Number: PA17-07V06

Art Unit: 2877

Examiner: Sang H. Nguyen

Search string: (5414514 or 5808742 or 6522411).pn

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
	1	5414514	1995-05-09	Smith et al.			
	2	5808742	1998-09-15	Everett et al.			
	3	6522411	2003-02-18	Moon et al.	B1		

Signature

Examiner Name	Date